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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application

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Date of Deposit:	12/16/03	Name of Person Making the Deposit:	Jacqueline Coyne	Signature of the Person Making the Deposit:
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In re Application

Inventor(s): Fan ZHONG and Jonathan G. BORNSTEIN

Serial No.: 09/874,434

Filed: 6/4/01

Title: HIGH-DENSITY PLASMA DEPOSITION PROCESS FOR FABRICATING A TOP CLAD FOR PLANAR LIGHTWAVE CIRCUIT DEVICES

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**NOTIFICATION OF FILING OF CONTINUATION APPLICATION CLAIMING
 BENEFIT OF FILING DATE
 (THIS IS NOT A REQUEST FOR A CPA FILING)**

Notification is hereby being made of the filing of a continuation application claiming benefit for filing date for this case

concurrently herewith.
 on

Please direct all correspondence concerning the above-identified application to the following address:

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Respectfully submitted,

Date: December 16, 2003

By: 
 Glenn D. Barnes
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